

07-10-2001

Docket No. 12179-P098US

Place of Form PTO-1595



T 7.701

To the Assistant Commissioner of Patents and Trademarks, 101771493 documents or copy thereof.

the attached original

1. Name of conveying party(ies):

Seiichi Iwamatsu

2. Name and address of receiving party(ies):

SI Diamond Technology, Inc. 3006 Longhorn Blvd., Suite 107 Austin, Texas 78758

3. Nature of conveyance:

X Assignment

Execution Date: May 16, 2001

4. Application number(s) or patent number(s):

If this document is being filed together with a new application, the execution date of the application is

A. Patent Application No.(s) 09/836,857

B. Patent

5. Name and address of party to whom correspondence concerning document should be mailed:

Kelly K. Kordzik Winstead Sechrest & Minick P.C. 5400 Renaissance Tower 1201 Elm Street Dallas, TX 75270 (512) 370-2851

6. Total number of applications and patents involved: 1

7. Total fee (37 CFR 3.41) \$ 40.00

Authorized to be charged to deposit account X Check enclosed

8. Deposit account number:

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9. Statement and signature.

To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.

Kelly K. Kordzik Name of Person Signing

Signature

6/25/01 Date

Total number of pages including cover sheet: 2

207:12179-P098US

ASSIGNMENT

Whereas, I,

(1) Seiichi Iwamatsu, of 10-58 Naka Ohshio
Chino, Nagano 391-0215
Japan

have invented certain improvements in

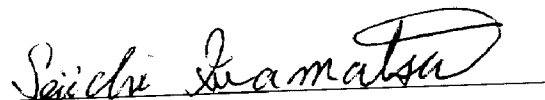
ELECTRON BEAM DUPLICATION LITHOGRAPHY
METHOD AND APPARATUS

and executed, respectively, a United States patent application therefor on (*Dates Inventors Signed Declaration*) (1) May 16, 2001.

Whereas, SI DIAMOND TECHNOLOGY, INC., a corporation of Texas, having a place of business at 3006 Longhorn Blvd., Suite 107, Austin, Texas 78758 (hereinafter called SIDT), desires to acquire the entire right, title and interest in the said application and inventions, and to any United States and foreign patents to be obtained therefor;

Now, therefore, for a valuable consideration, receipt whereof is hereby acknowledged, we, the above named, hereby sell, assign, and transfer to SIDT, its successors and assigns, the entire right, title and interest in the said application and inventions therein disclosed for the United States and foreign countries, and all rights of priority resulting from the filing of said United States application, and we request the Commissioner of Patents to issue any Letters Patent granted upon the inventions set forth in said application to SIDT, its successors and assigns; and we hereby agree that SIDT may apply for foreign Letters Patent on said inventions and we will execute all papers necessary in connection with the United States and foreign applications when called upon to do so by SIDT.

(1) Signed at Japan, on May 16, 2001.


Seiichi Iwamatsu